

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

December 29, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG756524088

LABORATORY GROWN DIAMOND

EMERALD CUT

8.56 X 5.75 X 3.94 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.01 CARATS

D

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence


EXCELLENT

EXCELLENT

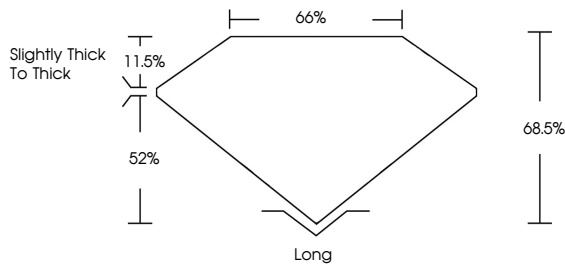
NONE

Inscription(s)

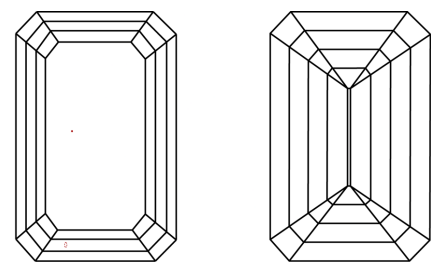
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG756524088

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3


Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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EMERALD CUT

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Carat Weight

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Clarity Grade

Depth

Table

Girdle

Slightly Thick To Thick

Long

Polish

Symmetry

Fluorescence

Inscription(s)

2.01 CARATS

D

VVS 2

68.5%


65%

Long

EXCELLENT

EXCELLENT

NONE

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